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Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Dominik EISERT et al.

Serial No.: 10/523,551

Filed: October 18, 2005

For: GaN-Based Radiation-Emitting Thin-Layered  
Semiconductor Component

Examiner:

Group Art: 2812

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August 4, 2008

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Thomas Langer  
Name of applicant, assignee or Registered Representative

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Signature

August 4, 2008

Date of Signature

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

LETTER

SIR:

The IDS filed October 22, 2007 submitted US 2006/0097271. However, this document is the published application of the above-referenced application. Therefore, it should not be listed as a prior art document.

It is respectfully requested that this document be deleted from the list of prior art.

Respectfully submitted,  
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